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http://scitation.aip.org/content/aip/journal/apl/44/1/10.1063/1.94589
Title: Fabrication of high quality sub-micron Au gratings over large areas with pulsed laser interference lithography for SPR sensors
http://arxiv.org/abs/1302.2660?context=physics

Abstract In order to study the feasibility of submicron lithography using second-harmonic light (SHL) at wavelength of 255.3 nm of copper vapor laser (CVL), a 1:1
http://adsabs.harvard.edu/abs/1997SPIE.3051..967H

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Abstract We present results of our evaluation of the X-ray lithographic technique for replication of submicron patterns generated by electron beam.
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Femtosecond laser lithography technique for submicron T-gate fabrication on positive photoresist. Technical Institute of Physics and Chemistry,
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Fabrication of submicron structures in nanoparticle/polymer composite by holographic lithography and reactive ion etching A. Ping Zhang, Sailing He, Kyoung Tae Kim
http://physics.anu.edu.au/get_pdf.php?PubID=U9912193XPUB211

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This monograph details the physics behind the methods of generating submicron forms for electron beam, ion beam, optical, and X-ray lithography.
http://www.worldcat.org/title/physics-of-submicron-lithography/oclc/840285075

The Japan Society of Applied Physics Study of Hydrogen Vacuum-Ultraviolet Light Sources for Submicron Lithography Kazuhiro Kudo, Takashi Iwabuchi 1, Katsuhiko
http://iopscience.iop.org/1347-4065/29/11R/2572/

A soft-imprint technique for submicron structure fabrication via in situ polymerization Nanoimprint Lithography Using Novolak-Type Photoresist and Soft Mold at
http://m.iopscience.iop.org/0957-4484/15/1/026

Institute of general physics of USSR Academy of Sciences, Introduction Production of high performance VLSI's requires effective methods of submicron lithography.
http://www.sciencedirect.com/science/article/pii/0167931785900449

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X ray lithography was studied, using laser produced plasma as a source. A single target shot of a frequency tripled Nd:glass laser (=0.35 m, 35 J in 1 ns
http://scitation.aip.org/content/aip/journal/apl/43/7/10.1063/1.94535

Jun 01, 2005 Physics > Atomic Physics. Title: Two-dimensional atomic lithography by sub-micron focusing of atomic beams. Authors: W. Williams, M. Saffman
http://arxiv.org/abs/physics/0506022

This book is devoted to the physics of electron-beam, ion-beam, optical, and x-ray lithography. The need for this book results from the following considerations.
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Recent developments in electron beam lithography S. Radelaar Center for Submicron Technology, Faculty of Applied Physics Lorentzweg 1, 2628 CJ Delft, The Netherlands
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X-Ray Lithography and Microscopy for Submicron Structures /21 (Boris W. Batterman, director of the School of Applied and Engineering Physics,
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